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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Yuchun Wang, Rajeev Bajaj and Fred C. Redeker
Serial No. : 09/843,582
Filed : April 26, 2001
For : ION EXCHANGE PAD OR BRUSH AND METHOD OF
REGENERATING THE SAME
Examiner : Dung V. Nguyen
Group Art Unit : 3723

Hon. Assistant Commissioner
for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER R3700

AMENDMENT

Sir:

In response to the Examiner's Office Action dated
October 11, 2002, applicants amend the above-identified
application as follows:

In the Claims

Please amend claims as follows:

BI
14. A brush apparatus comprising:
a scrubber brush having:
a surface adapted to contact a surface of a
substrate to be scrubbed; and